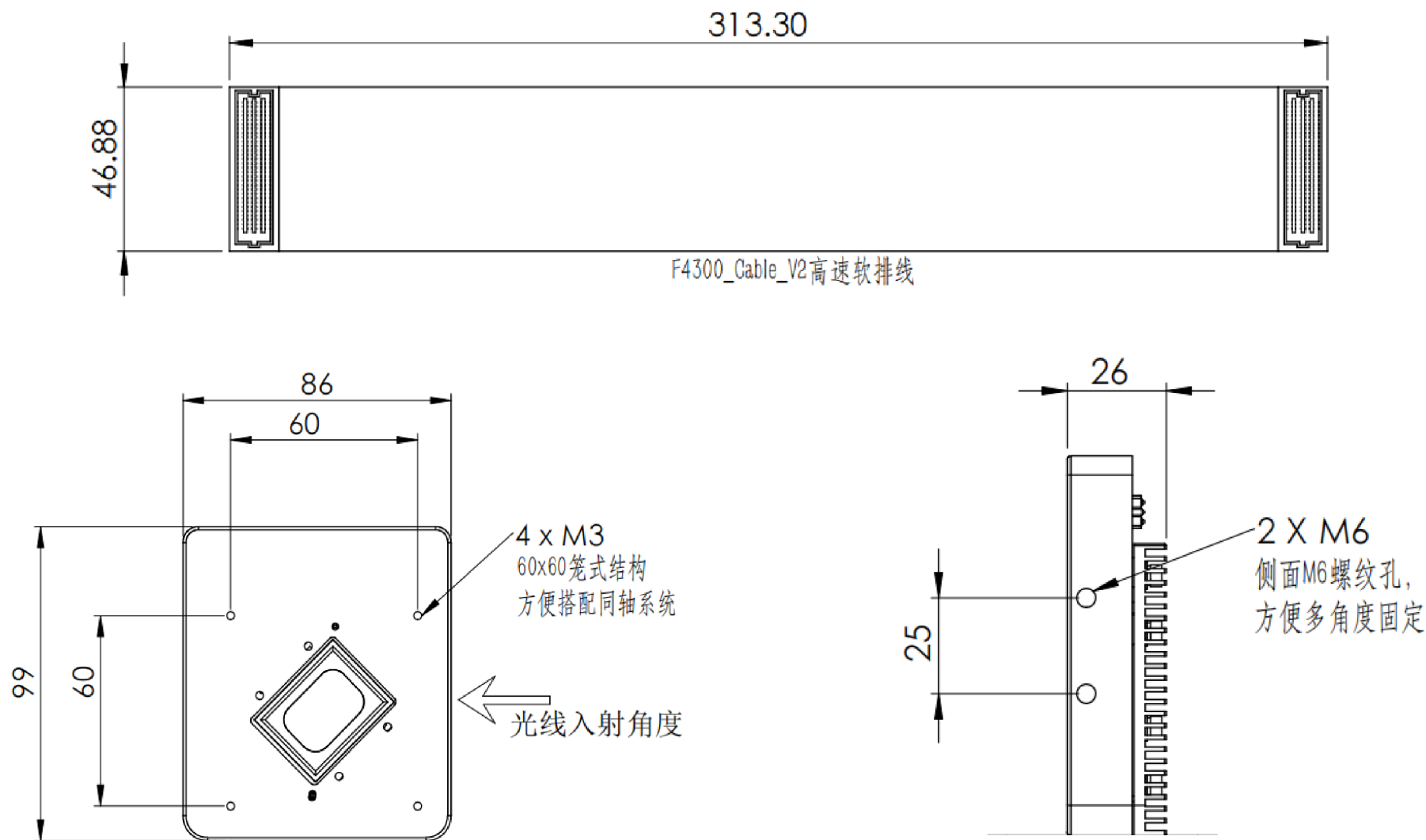




DRAWING PROJECTION			LBTEK			
	NAME	DATE	DMD—DDR0.55XGA			
DRAWN	PNIU	MAR./10th/25	Ultrahigh—speed Digital Micromirror Spatial Light Modulator			
APPROVAL	EYANG	MAR./10th/25	MATERIAL	WEIGHT	SCALE	REV
FOR INFORMATION ONLY NOT FOR MANUFACTURING PURPOSES				g		A